Growth of Nano- and Microstructured Indium Nitride Crystals by the Reaction of Indium Oxide with Ammonia

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Nano- and microstructured indium nitride crystals were synthesized by the reaction of indium oxide (In_2O_3) powder and its pellet with ammonia in the temperature range 580-700 °C. The degree of nitridation of In_2O_3 to InN was very sensitive to the nitridation temperature. The formation of zero- to three-dimensional structured InN crystals demonstrated that In_2O_3 is nitridated to InN *via* two dominant parallel routes (solid (In_2O_3)-to-solid (InN) and gas (In_2O)-to-solid (InN)). The growth of InN crystals with such various morphologies was explained by the vapor-solid (VS) mechanism where the degree of supersaturation of In vapor determines the growth morphology and the vapor was mainly by the reaction of In_2O with ammonia and partially by sublimation of solid InN. The pellet method was proven to be useful to obtain homogeneous InN nanowires.

Key Words : Indium nitride, Indium oxide, Nanowires, Growth mechanism, VS mechanism

Introduction

Indium nitride (InN), one of Group 13 nitrides, with a direct bandgap of 1.9 eV is a promising material for optoelectronic devices, low-cost solar cells with high efficiency, optical coatings and various sensors.¹ However, it remains one of the least studied Group 13 nitrides because of the inherent difficulty of its preparation in stoichiometric form. The equilibrium vapor pressure of N2 over InN is much higher than that over other Group 13 nitrides such as GaN and AlN, and the In-N bond is the weakest of these nitrides.² InN films have been prepared by various methods such as reactive magnetron sputtering, metalorganic chemical vapor deposition (MOCVD) and molecular-beam epitaxy (MBE).³ However, up to now there is little information concerning synthetic methods of InN powders.⁴⁻⁶ And onedimensional structured InN has been reported in recent years. 7-13

In this report, nano- and microstructured InN crystals were synthesized by the reaction of indium oxide (In_2O_3) powder and its pellet with ammonia. The pellet contains a mixture of In_2O_3 and Al_2O_3 powders. It will be shown that the pellet method is useful for preparation of InN nanowires. The plausible reaction mechanism on conversion of In_2O_3 to InN and growth mechanism of InN crystals will be suggested on the basis of various morphologies of InN crystals formed.

Experimental Section

The precursor material, indium oxide (In_2O_3) in cubic phase (Kojundo Chemical Lab Co., 99.99%), was used without further purification. The In_2O_3 powder in an alumina crucible was set in an alumina tube with an inner diameter of 33 mm and heated at a rate of 5 °C min⁻¹ to the reaction temperature (580-700 °C) under an ammonia (Showadenko Co., 99.999%) flow of 500 mL min⁻¹ with varying the duration time. Care was taken to keep the crucible closest to the thermocouple of the furnace to ensure that the temperature of the furnace matches with that of the crucible. The sample nitridated was taken from the furnace after it was cooled to the room temperature under a flow of ammonia. InN nanowires were obtained by calcining pellets containing a homogeneous mixture of In_2O_3 and Al_2O_3 (mole ratio = 0.1 : 1) powders. The pellets were prepared in disc form of 1 cm radius and 0.5 mm thickness by using a die and a hydraulic press. A pellet was put on another pellet, followed by being nitridated in flowing ammonia.

The conversion of In_2O_3 to InN was monitored by the weight loss and XRD (Rigaku DMX-2500 diffractometer with Cu-K α radiation operating at 40 kV and 100 mA). The morphology of InN products was investigated by scanning electron microscopy (SEM, Hitachi S-4100), transmission electron microscopy (TEM, Philips CM 200 STEM at 200 kV), and selected-area electron diffraction (SAED).

Results and Discussion

Nitridation of In_2O_3 Powder by Ammonolysis. The precursor material, In_2O_3 in cubic phase, was nitridated to InN by ammonolysis at different reaction temperatures varying the duration time. Figure 1 shows XRD patterns of samples synthesized at different temperatures. The degree of nitridation of In_2O_3 to InN was very sensitive to the nitridation temperature. Figure 1(a) shows that the sample nitridated at 580 °C for 8 h has diffraction peaks (JCPDS Card No. 2-1450) assigned to InN together with those assigned to unreacted In_2O_3 . The intensities of the former peaks increased with the nitridation temperature. As shown Growth of Nano- and Microstructured Indium Nitride Crystals

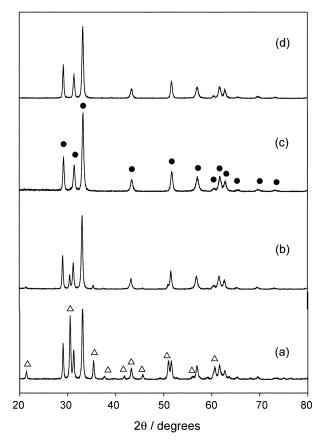


Figure 1. XRD patterns of powders obtained by nitridation of In_2O_3 in flowing ammonia at (a) 580 °C for 8 h, (b) 600 °C for 8 h, (c) 600 °C for 12 h, and (d) 620 °C for 8 h. (\bullet) InN, (\triangle) In₂O₃.

in Figure 1(c), the nitridation of In_2O_3 to InN was complete at 600 °C for 12 h. At temperatures above 600 °C the shorter duration time was required for the complete nitridation, as shown in Figure 1(d). The nitridation above 620 °C for 20 h caused InN products to swell like a cotton candy and indium droplets to be observed at the bottom of the alumina crucible because of decomposition of InN into indium metal and N_2 gas.

The conversion of In₂O₃ to InN by ammonolysis was accompanied by weight loss (which is defined by 100(1weight of the product/weight of the precursor used)). The weight loss of 7.2% will be obtained theoretically if there is no loss of In species from the reaction system during the nitridation reaction and In₂O₃ is completely converted to InN. If the reaction temperature was higher than 620 °C and the duration time was longer than 8 h, the single phase of InN was detected by XRD but the weight loss was higher than 7.2%. The latter fact is mainly ascribed to decomposition of InN into metallic In and N2 and partially ascribed to sublimation of InN. As the reaction temperature became higher than 640 °C, the yield of InN powder abruptly decreased along with increase in the amount of In metal. For example, the yield of an InN product was around 1 % for the nitridation at 700 °C for 4 h. As a consequence, the optimum temperature range is very narrow (600 to 620 °C) for preparation of InN products in good yield.

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The SEM micrographs of as-synthesized InN products demonstrated that their morphology is strongly dependent on the nitridation temperature. Figure 2(a) shows the morphology of InN products obtained at 600 °C for 12 h, which were still particles. Their size was much lager than that of the precursor (In_2O_3) powders. As shown in Figure 2(b), InN products synthesized at 610 °C for 20 h consisted of short nanorods with a conical tip. Figure 2(c) shows the morphology of InN powders obtained at 630 °C for 20 h, most of them being mainly nanorods with a diameter of ca. 130 nm. The longer duration time (~40 h) at 630 °C led to the formation of microplates as well as nanorods. InN products prepared in the temperature range 630-680 °C were a mixture of nanorods and microplates. InN products formed at 700 °C for 4 h involved some hollow microtubes and lobster shell-like microstructures besides nanorods and microplates, as shown in Figure 2(d).

Figure 3(a) shows a TEM image of the InN nanorod obtained at 620 $^{\circ}$ C for 20 h. The long axis of the nanorod is normal to the (0001) plane, with the preferred direction being [001]. The selected area electron diffraction (SAED) pattern (Figure 3(b)) indicates high crystallinity of the nanorods.

The dramatic change in morphology with temperature indicates the involvement of any gaseous In species in conversion of In₂O₃ to InN. The predominant gaseous species is most likely to be In₂O, which is formed mainly by the reaction between In₂O₃ and In and partially by the decomposition of In₂O₃.¹⁴ Therefore, we suggest that there would be two dominant parallel routes in conversion of In_2O_3 to InN by ammonolysis, *i.e.*, solid (In_2O_3) -to-solid (InN) and gas (In₂O)-to-solid (InN) conversion routes. At the initial stage InN is formed by the solid-to-solid conversion route and then decomposes into metallic In and nitrogen. The metallic In reacts with In₂O₃, leading to the formation of gaseous In2O. The reaction of the resulting In₂O with ammonia, which is expected to be fast because of a gas-gas reaction, yields InN. As a result, the main conversion routes from In2O3 to InN are summarized as follows:

Route I: In₂O₃(s) + 2 NH₃(g) \rightarrow 2 InN (g, s) + 3 H₂O (g) (1)

Route II:

2

$$InN(g, s) \rightarrow 2 In (l) + N_2 (g)$$
⁽²⁾

$$In_2O_3(s) + 4 In(1) \rightarrow 3 In_2O(g)$$
 (3)

$$In_2O(g) + 2 NH_3(g) \rightarrow 2 InN(g, s) + H_2O(g) + 2 H_2(g)$$
(4)

At relatively low temperatures (below 600 °C) Route I prevails over Route II. InN products prepared by Route I take a form of particle, as shown in Figure 2(a). With increasing temperature Route II becomes more distinct, leading to the formation of InN products with various morphologies, as shown in Figure 2(b)-(d). Some investigators synthesized InN nanowires though a combination of (3) and (4) reactions, *i.e.*, by the reaction of a mixture of

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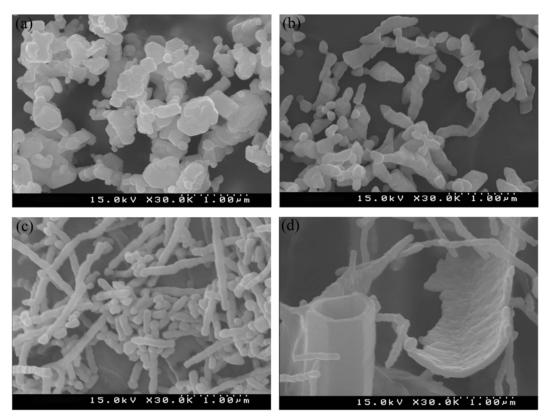


Figure 2. SEM micrographs of InN powders obtained by nitridation of In_2O_3 in flowing ammonia at (a) 600 °C for 12 h, (b) 610 °C for 20 h, (c) 630 °C for 20 h, and (d) 700 °C for 4 h.

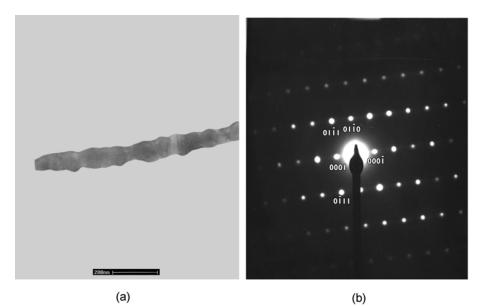


Figure 3. High-magnification TEM image of the InN nanowire obtained by nitridation of In_2O_3 in flowing ammonia at 630 °C for 20 h: (a) bright-field image, the direction of the axis is [001]. Bar = 200 nm; (b) SAED pattern, the zone axis is $[2\overline{1}\overline{1}0]$.

 In_2O_3 and In with ammonia.^{8,11} The reaction mechanism proposed in this work is quite different from that suggested by Gao *et al.*⁵ where metallic In formed by reduction of In_2O_3 by H₂ reacts with N₂, resulting in formation of InN. The H₂ and N₂ are derived from decomposition of NH₃.

The growth of In crystals with various morphologies from vapor phase is explained by the vapor-solid (VS) growth

mechanism where the degree of supersaturation determines the prevailing growth morphology.¹⁵ A low supersaturation is required for growth of one-dimensional (1D) structures whereas a medium supersaturation supports bulk crystal growth; an intermediate supersaturation is evidenced by the growth of two-dimensional (2D) platelets. None of the InN nanorods formed from In₂O₃ powders in this work showed

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characteristic vapor-liquid-solid (VLS) droplets on their tips, as shown in Figures 2(b), 2(c), and 3(a); although this observation does not exclude the VLS mechanism, it does suggest growth through the VS mechanism. Kato and Tamari suggested that at the initial stage, the formation of one-dimensional structures proceeded by the VLS mechanism, followed by the removal of droplets by evaporation and continued growth by the VS mechanism.¹⁶ It is possible that their mechanism was responsible for nanorod growth in the present study. In this case, the molten indium would serve as a catalyst.

Two-dimensional (2D) microstructures such as microplates and lobster shell-like microstructures were also observed (Figure 2(d)), indicating that there were some local regions under an intermediate supersaturation. Hollow microtubes are likely to be formed through the twodimensional microstructure under an intermediate supersaturation (see below). Some microtubes had holes at their walls because of lack in feed of InN vapor. The morphology became more diverse with increasing the reaction temperature because the overall degree of supersaturation would increase with the temperature. Thus, the local degree of supersaturation within powders may have played a crucial role on the morphology distribution of the formed InN products.

Nitridation of In₂O₃ Pellets by Ammonolysis. As seen

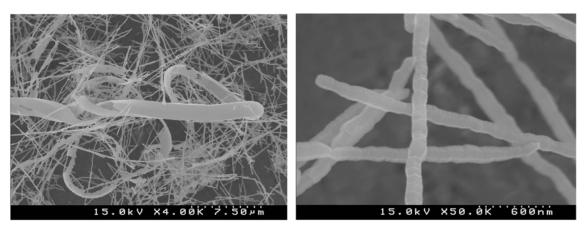


Figure 4. SEM micrographs of the InN product obtained by nitridation of In₂O₃ pellets at 620 °C for 40 h in flowing ammonia.

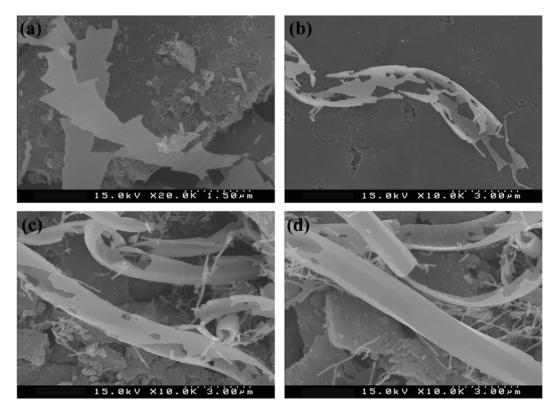


Figure 5. SEM micrographs showing the formation process ($a \rightarrow b \rightarrow c \rightarrow d$) of a hollow microtube. The InN sample was obtained by nitridation of In₂O₃ pellets at 700 °C for 5 h in flowing ammonia.

from above-mentioned results, the 1D structure of InN obtained from In_2O_3 powders was not a nanowire but a nanorod. Nanowires can be easily synthesized by a pellet method. In a previous report¹⁷ we synthesized GaN nanowires by the pellet method, in which GaN vaporizes and a confined space formed by pressing a matrix material therby becomes supersaturated with GaN vapor. To obtain InN nanowires In_2O_3 pellets were prepared by pressing a homogeneous mixture of In_2O_3 and Al_2O_3 powders, leading to confinement of In_2O_3 in an Al_2O_3 matrix. A pellet was put on another pellet and then nitridated by ammonia. InN products including many nanowires were found both within the interspace between two pellets and on two surfaces confronting two pellets each other, whereas no InN products were found on the other two surfaces of pellets.

Figure 4 shows SEM micrographs of the InN product which was obtained at 620 °C for 40 h. The distribution of their morphologies was quite different from that of InN products obtained by using In_2O_3 powders under the same condition. The InN product consisted of nanowires with a diameter of ~100 nm, lobster shell-like microstructures and imperfect hollow microtubes. The InN product obtained at 700 °C for 5 h involved nanowires, flat microplates, lobster shell-like microstructures, and hollow microtubes. Figure 5 demonstrates the formation process of a hollow microtube. The microtube may be a two-dimensional microstructure at its initial stage, as shown in Figure 5(a). By continuous feeding of InN vapor the microstructure transforms into a three-dimensional microstructure (Figure 5(d)) through those of Figures 5(b) and (c).

The growth of nano- and microstructured InN crystals from In₂O₃ pellets is also explained by the VS mechanism as follows. In₂O₃ in a confined space below the surfaces of pellets is nitridated to InN by ammonia and then In₂O vapor is formed by a combination of (2) and (3) reactions of Route II. The In₂O vapor comes out into the interspace and then convert to InN by the reaction (4). The interspace is supersatutared with InN vapor, followed by nucleation and growth of InN crystals. The fact that most of InN crystals were nanowires indicates that the degree of supersaturation within the interspace is controlled at a low level. The distribution of InN nano- and microstructures was not homogeneous within the interface but different from region to region, indicating that the degree of supersaturation was not the same throughout the interspace. The local difference in the morphology strongly suggests that InN nano- and microstructures grow independently except the transformation of two- into three-dimensional microstructures. This is contrary to the growth mechanism proposed by Schwenzer et al.¹⁰ where InN nanoparticles transform into nanowires and then into hollow microtubes.

The reason why no InN products were found on the upside surface of the upper pellet and the downside surface of the lower pellet is that In₂O vapor formed in the confined spaces easily scatters and does not supersaturate enough to nucleate because the spaces are open outward. Woo-Sik Jung et al.

Conclusions

Nano- and microstructured InN crystals with a variety of morphologies were synthesized by the reaction of In2O3 powder and its pellet with ammonia at different temperatures. The reaction temperature should be controlled between 600 and 620 °C in order to obtain InN product from In₂O₃ powder in good yield. The growth of nano- and microstructured InN crystals was explained by the VS growth mechanism where the main morphology-determining factor is the degree of supersaturation. The In vapor in the VS mechanism is believed to be formed mainly by the reaction of gaseous In₂O with ammonia and partially by sublimation of solid InN. The local difference in the morphology strongly suggests that InN nano- and microstuctures grow independently except the transformation of two- into three-dimensional microstructures. The pellet method was proven to be useful to obtain homogeneous InN nanowires.

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